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Docket No. 740756-2296

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: )  
Hisashi OHTANI et al. ) Group Art Unit: 2815  
Serial No. 09/837,552 ) Examiner: N. Drew Richards  
Filed: April 19, 2001 ) Confirmation No. 7555  
For: SEMICONDUCTOR DEVICE AND ) Date: November 5, 2003  
MANUFACTURING METHOD  
THEREOF

**REQUEST FOR ACKNOWLEDGEMENT OF  
INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

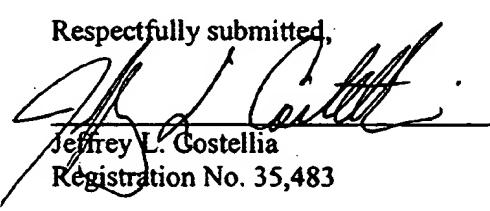
Sir:

Information Disclosure Statements with Forms PTO-1449 was filed in the above-identified patent application on July 14, 2003. Applicants have not yet received back from the Examiner a copy of the Forms PTO-1449 initialed to acknowledge the fact that the Examiner has considered the cited disclosed information.

The Examiner is requested to initial and return to the undersigned a copy of the subject Forms PTO-1449.

Should there be any questions concerning this communication, please telephone the undersigned at the number set forth below.

Respectfully submitted,

  
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**Match and Return**